PROSENTAL PROSEN

Docket No.: 50103-433 **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of

hanwei LIU, et al.

Serial No.: 10/047,105

Group Art Unit: 1756

Filed: January 16, 2002

Examiner: not yet assigned

For: RESIST REMOVAL FROM PATTERNED RECORDING MEDIA

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

WDC99 595037-1.050103.0433

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Aaron Weisstuch, Ph.D. Registration No. 41,557

600 13th Street, N.W. Washington, DC 20005-3096 (202)756-8000 AW:mlw Facsimile: (202)756-8087

Date: May 2, 2002